



Docket No.: M4065.0466/P466
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Neal Rueger

Application No.: 09/938,644

Art Unit: 1765

Filed: August 27, 2001

Examiner: A.K. Alanko

For: METHOD AND APPARATUS FOR
MICROMACHINING USING A MAGNETIC
FIELD AND PLASMA ETCHING

AMENDMENT

MS Non-Fee Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated August 13, 2003 (Paper No. 9), please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

Please consider the **Remarks**, beginning on page 12 of this paper.

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